

Electronic Patent Application Fee Transmittal

Application Number:	10081818			
Filing Date:	20-Feb-2002			
Title of Invention:	ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW ASYMMETRICAL TUNNEL BARRIER INTERPLOY INSULATORS			
First Named Inventor:	Jerome M. Eldridge			
Filer:	David Ross Cochran/Judy Dent			
Attorney Docket Number:	1303.045US1			
Filed as Large Entity				
Utility	Filing Fees			
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Submission- Information Disclosure Stmt	1806	1	180	180
Total in USD (\$)				180